



PATENT

Atty. Dkt. No. AMAT/5333.Y1/DISPLAY/AKT/RKK

1746  
JFW

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:  
Sheng Sun

Serial No.: 09/866,225

Confirmation No.: 5889

Filed: May 24, 2001

For: Chamber Cleaning Via Rapid  
Thermal Process During a  
Cleaning Period§  
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Group Art Unit: 1746

Examiner: Alexander Markoff

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450CERTIFICATE OF MAILING  
37 CFR 1.8I hereby certify that this correspondence is being deposited on  
May 26, 2004 with the United States Postal Service as First  
Class Mail in an envelope addressed to: Mail Stop  
Amendment, Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450.May 26, 2004  
Date

Signature

Dear Sir:

## RESPONSE TO OFFICE ACTION DATED FEBRUARY 27, 2004

In response to the Office Action dated March 27, 2004, having a shortened statutory period for response set to expire on May 27, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5333.Y1/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.